

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Jiang Hsieh et al. : Art Unit: 2624  
Serial No.: 10/749,033 : Examiner: Bloom, Nathan J.  
Filed: December 30, 2003 :  
For: METHODS AND APPARATUS FOR :  
ARTIFACT REDUCTION :  
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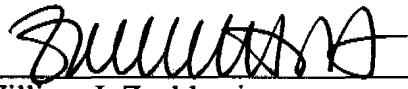
**SUMMARY OF EXAMINER INTERVIEW**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

In response to the Notice of Allowability dated May 12, 2008 and the Interview Summary provided therewith by the Examiner, Applicants acknowledge that a telephonic interview was conducted regarding the above-referenced patent application on April 29, 2008. Participants of this interview were Examiner Nathan Bloom and William Zychlewicz.

Applicants wish to thank the Examiner for the courtesies he extended to the Applicants' representative during the telephonic interview. During the interview, an agreement was reached to place the patent application in condition for allowance. More specifically, the participants reached an agreement on an Examiner's Amendment to cancel Claims 1-7 and to correct a few minor deficiencies. As a result, the patent application was placed in condition for allowance.

Respectfully submitted,

  
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